## STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Norio FUKASAWA et al

Serial Number: 09/029,608

Group Art Unit: 2814

Filed: May 15, 1998

Examiner: Graybill, D.

For:

METHOD AND MOLD FOR MANUFACTURING SEMICONDUCTOR DEVICE. SEMICONDUCTOR DEVICE AND METHOD FOR MOUNTING THE

## INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents Washington, D.C. 20231

March 19, 2002

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached along with a Chinese Office Action (with translation).

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the abovecaptioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a) concerning the PTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

Stephen G. Adrian Attorney for Applicants Reg. No. 32,878

Atty. Docket No. 980233 1725 K Street, N.W., Suite 1000 Washington, DC 20006

Tel: (202) 659-2930 Fax: (202) 887-0357

SGA/arf

Enclosures: PTO-1449, 4 references and Chinese Office Action (with translation)